

DOCKET NO: 241807US2 DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TOSHIAKI IWAMATSU ET AL. :
SERIAL NO: NEW APPLICATION : ATTN: APPLICATION DIVISION
FILED: HEREWITH :
FOR: SEMICONDUCTOR DEVICE AND :
METHOD OF MANUFACTURING THE :
SAME

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend this application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 10 of this paper.